



THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Farnworth et al.

Serial No.: 10/801,205

Filed: March 16, 2004

For: STRESS AND FORCE  
MANAGEMENT TECHNIQUES FOR A  
SEMICONDUCTOR DIE

Confirmation No.: 3129

Examiner: E. Lee

Group Art Unit: 2811

Attorney Docket No.: 2269-5774US  
(01-1281.00/US)

PATENT

*interview w/ACG  
12/8/16  
Suresh  
4/4/17*

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

November 2, 2006  
Date

*Leta M. Howard*  
Signature

Leta M. Howard  
Name (Type/Print)

AMENDMENT UNDER 37 C.F.R. § 1.116

MAIL STOP AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This amendment is in response to the Final Office Action of September 8, 2006, whose initial period of response is set to expire on December 8, 2006. This response is submitted on or before two months from the mailing date of the Final Office Action.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 15 of this paper.